



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q92097

Akemitsu IIDA, et al.

Appln. No.: 10/560,980

Group Art Unit: Unknown

Confirmation No.: 3728

Examiner: Unknown

Filed: December 16, 2005

For: GAS PROCESSING METHOD AND GAS PROCESSING APPARATUS UTILIZING
OXIDATION CATALYST AND LOW-TEMPERATURE PLASMA

SUBMISSION OF EXECUTED DECLARATION

MAIL STOP PCT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In view of the application filed on December 16, 2005 without the appropriate executed documents, and since Applicant's attorney has not yet received the "Notification of Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US)," for the above application, Applicant submits herewith a copy of the Declaration for the above identified application properly executed by the inventors.

A check for the statutory fee of \$130.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this paper is attached.

01/27/2006 GFREY1 00000115 10560980

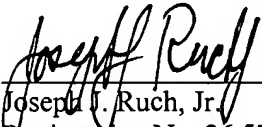
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Respectfully submitted,



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Date: January 26, 2006